

Sheet 1 of 1

Form PTO-1449					Docket No. P-00,1958		Serial No. 09/743929	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Applicant Gohlke et al			
					Filing Date		Group Art Unit	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
qr	AA	5,102,720	04/07/92	Raj	—	—		
qr	AB	5,769,987	06/23/98	Gurkovich et al	—	—		
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
qr	AL	42 43 040	06/24/93	Germany				X
1	AM	196 28 680	01/30/97	Germany				X
	AN	06-97656	04/08/94	Japan			Abstract	
qr	AO	WO 96/39298	12/12/96	International				
	AP							
	AQ							
	AR							
	AS							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AT	Wilcox et al, "The Multilayer Ceramic Integrated Circuit (MCIC) Technology: Opportunities and Challenges", 1997 International Symposium on Microelectronics, pp. 17-23.						
	AU							
	AV							
	AW							
Examiner <i>qpl ml</i>				Date Considered <i>10/3/02</i>				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								